

123103 16519 U.S. PTO

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22386 U.S. PTO
10/750023
123103

Atty. Docket No.: AB-1350 US

December 31, 2003

Mail Stop Patent Application
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Enclosed herewith for filing is a patent application, as follows:

Inventor: LEE, Ho
Title: CHEMICAL VAPOR DEPOSITION APPARATUS
☒ Return Receipt Postcard
☒ This Transmittal Letter (in duplicate)
4 page(s) Specification and 1 page(s) Title Page (not including claims)
2 page(s) Claims
1 page Abstract
2 sheet(s) of Drawings (consisting of Figs. 1, 2, and 3)
2 page(s) Declaration for Patent Application and Power of Attorney
1 page(s) Change of Correspondence Address

CLAIMS AS FILED

For	Number Filed		Number Extra		Rate		Basic Fee
Total Claims	9	-20 =	0	X	\$18.00 =	\$	770.00
Independent Claims	2	-3 =	0	X	\$86.00 =	\$	0.00
<input type="checkbox"/>	Fee of _____ for the first filing of one or more multiple dependent claims per application						\$
<input type="checkbox"/>	Fee for Request for Extension of Time						\$

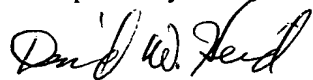
Please make the following charges to Deposit Account No. 50-2257:

- ☒ Total fee for filing the patent application in the amount of \$ 770.00
☒ The Commissioner is hereby authorized to charge any additional fees which may be
required, or credit any overpayment to Deposit Account No. 50-2257.

EXPRESS MAIL LABEL NO:

EV 302 216 405 US

Respectfully submitted,



David W. Heid
Attorney for Applicant
Reg. No. 25,875

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: LEE, Ho
Assignee: Samsung Electronics Co., Ltd.
Title: CHEMICAL VAPOR DEPOSITION APPARATUS
Application No.: Unknown Filing Date: Herewith
Examiner: Unknown Group Art Unit: Unknown
Docket No.: AB-1350 US

San Jose, California
December 31, 2003

Mail Stop Patent Application
COMMISSIONER FOR PATENTS
P.O. Box 1450
Alexandria, VA 22313-1450

CHANGE OF CORRESPONDENCE ADDRESS

Dear Sir:

Pursuant to 37 C.F.R. § 1.33(a)(2), the undersigned principal attorney of record hereby requests that the correspondence address for the above-referenced patent application be changed to:

David W. Heid
MacPherson Kwok Chen & Heid LLP
1762 Technology Drive, Suite 226
San Jose, CA 95110

The daytime telephone number of the undersigned Attorney for Applicant is (408) 392-9250. The Examiner is requested to telephone the undersigned Attorney for Applicant, if the Examiner has any question regarding the above.

EXPRESS MAIL LABEL NO.:

EV 302 216 405 US

Respectfully submitted,



David W. Heid
Attorney for Applicant
Reg. No. 25,875

LAW OFFICES OF
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